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PATENT APPLICATION

**RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 2822**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Nobuaki HASHIMOTO

Group Art Unit: 2822

Application No.: 09/856,627

Examiner: I. Soward

Filed: May 24, 2001

Docket No.: 109609

For: **INTERCONNECT SUBSTRATE, SEMICONDUCTOR DEVICE, METHODS OF
FABRICATING, INSPECTING, AND MOUNTING THE SEMICONDUCTOR
DEVICE, CIRCUIT BOARD, AND ELECTRONIC INSTRUMENT**

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the September 9, 2003 Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.